



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Whe Application of

Tetsuya OTSUKI Group Art Unit: 2818

Application No.: 10/624,680 Examiner: L. TRAN

Filed: July 23, 2003 Docket No.: 116568

For: INTERCONNECT SUBSTRATE, SEMICONDUCTOR DEVICE, METHODS OF MANUFACTURING THE SAME, CIRCUIT BOARD, AND ELECTRONIC EQUIPMENT

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection, Notice of Allowance, or other action that closes prosecution (e.g., Quayle Action), but before payment of the Issue Fee. Attached is our Check No. 170516 in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p). Please credit or debit Deposit Account No. 15-0461 as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.
- I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(1).
- 2. The references were cited in a counterpart foreign application. A partial English language translation of the office action is attached for the Examiner's information.
- 3. English language Abstracts of the non-English language references are attached hereto.
- 4. A computer-generated English language translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office

09/08/2005 HALI11 00000024 10624680

([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1-2.

Respectfully submitted,

Registration No. 27,075

Joel S. Armstrong Registration No. 36,430

Leana Levin Registration No. 51,939

JAO:JSA:LL/tlp

Date: September 6, 2005

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

SEP 0 8 2005

Sheet	1	of	1	
-------	---	----	---	--

Form PTO-1449 (REV. 8-83) US DEPARTMENT ACCE PATENT & TRADEMARK OFFICE		ATTY D 116568	ATTY DOCKET NO. 116568		APPLICATION NO. 10/624,680		
INFO:	RMATI	ION DISCLOSURE STATEMENT					
	(Use	several sheets if necessary)	APPLICA Tetsuya (- •	<u> </u>		
			FILING DATE July 23, 2003		GROUP 2818		
		U.S. P.	ATENT DOCU	JMENTS			
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAM	ſE	CLASS	SUB CLASS
		-					
					7 d		
	1						
							N-7-12
	-						
		FOREIGN	N PATENT DO	CLIMENTS			
-,		FOREIGN	TATENT DC	COMENTS			SUB
7.4		DOCUMENT NUMBER	DATE	COUNT	TRY	CLASS	CLASS
	1.	JP 11-163499 (06-18-1999	Japan			
1	2.	JP 11-274671	10-08-1999	Japan	**************************************		- *
				·			
							
		OTHER DOCUMENTS (Inclu	ding Author,	Title, Date, Pertinent Pag	ges, etc.)		
					www.		
EXAMINER					DATE CONSIDI	ERED	
Examiner: Ir	nitial if onform:	citation considered, whether or not citat ance and not considered. Include copy of t	tion is in conthis form with	formance with M.P.E.P. next communication to a	609; draw line th	rough citation	on if not in

Date: September 6, 2005